This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

- 1. (Currently Amended) A method of manufacturing a gas sensor having comprising:
 - a. providing a housing containing a reservoir;
 - b. which in use receives receiving an electrolyte in the reservoir;
- c. the method comprising the steps of: impregnating a substrate of a gas porous membrane with a conductive material, so that said conductive material defines an electrical pathway between an electrical contact on a first surface of the membrane and an electrode on a second surface of the membrane; and
 - d. arranging the membrane to seal the reservoir,

wherein the substrate of the gas porous membrane is impregnated with the conductive material by a wick.

- 2. (Currently Amended) A method according to claim 1 further including the step of attaching athe wick to the electrode.
- 3. (Original) A method according to claim 2 whereby the wick is pressed or sintered to the electrode.
- 4. (Original) A method according to claim 3 whereby the wick is sintered to the electrode at a temperature of between 300°C and 370°C.
- 5. (Currently Amended) A method according to claim [[4]]3 whereby the wick is sintered to the electrode at a temperature of between 320°C and 370°C.
 - 6. (Cancelled)
- 7. (Currently Amended) A method according to claim 1 whereby the gas porous membrane is impregnated by the conductive material is introduced into a substrate-via an the electrode.

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- 8. (Currently Amended) A method according to claim 1 whereby the gas porous membrane is impregnated by the conductive material is introduced into a substrate via an the external connection.
 - 9. (Cancelled)
- 10. (Currently Amended) A method according to claim 1 whereby gas porous membrane is impregnated by the conductive material in itsa melted state-is introduced into a substrate.
- 11. (Currently Amended) A method according to claim 1 whereby <u>the</u> electrodes and/<u>orthe</u> external <u>connectionscontact</u> are formed on <u>a substrate</u> the gas porous membrane by <u>any</u> one of <u>the following</u>:
 - (a) screen printing,;
- (b) filtering in selected areas from a suspension placed onto the substrategas porous membrane;; or
 - (c) spray coating, and
 - (d) sintering.
- 12. (Currently Amended) A method according to claim 1 whereby <u>the</u> electrodes areis formed on thea first face of the gas porous membrane that is opposite faces of a substrate to the external connections contact.
- 13. (Currently Amended) A method according to claim 8 whereby the electrodes are is formed on the a second face of the gas porous membrane that is the same face of the substrate as the external connections contact.
- 14. (Currently Amended) A method according to claim 1 wherein a substratethe gas porous membrane and the housing are bonded together using adhesive.
- 15. (Currently Amended) A method according to claim I1 wherein a substrate the gas porous membrane and the housing are bonded using heat and/or pressure so that a material forming the housing melts and impregnates the substrate gas porous membrane, thus forming a strong bond therebetween.

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- 16. (Currently Amended) A method according to claim 1 whereby the permeability of at least one region of a substrate the gas porous membrane to gas is decreased in order to limit the amount of gas reaching anthe electrode.
- 17. (Currently Amended) A method according to claim 16 whereby the permeability of at least one region of the substrategas porous membrane to gases is decreased by any one or combination of the following steps:
 - a) compressing the region;
 - b) impregnating the regions) with wax; or
 - c) impregnating the region(s) with a polymer₅. and a combination of any of steps a) to c).
 - 18. (Currently Amended) A gas sensor comprising:
- <u>a. at least first and secondan</u> electrodes formed on a planar substrategas porous membrane;
- <u>b.</u> a housing containing a reservoir, which wherein when, in use, the reservoir contains a liquid electrolyte for contacting the first and second electrodes;
- <u>c.</u> an electrical contact, <u>forconfigured to make an making</u> external <u>electrical</u> connection from the gas sensor; <u>and</u>
- <u>d.</u> a conductive material disposed between anthe electrode and the external electrical contact; and
- e. a wick being arranged to contact both the electrolyte and the electrode, the wick having at least one aperture formed therein through which the electrolyte can be introduced,

wherein at least a portion of the electrode and a portion of the substrategas porous membrane substantially adjacent thereto, is are impregnated with the conductive material, the conductive material forming an electrical pathway through the gas porous membrane which connects at least anthe electrode to the external electrical contact.

- 19. (Currently Amended) A gas sensor according to claim 18 wherein the electrodes and/or external connections the electrical contact are formed from a porous electrically conductive material containing a catalyst material.
- 20. (Currently Amended) A gas sensor according to claim 18 wherein the first electrode is a sensing electrode for creating the desired electrochemical reaction between the electrolyte and thea gas to be sensed₅.
- 21. (Currently Amended) A gas sensor according to claim 18 wherein the second electrode is a counter electrode which performs an electrochemical reaction with oxygen.
- 22. (Original) A gas sensor according to claim 18 further including a reference electrode.
- 23. (Original) A gas sensor according to claim 18 further including a gas generating electrode.
- 24. (Currently Amended) A gas sensor according to claim 18 wherein athe conductive massmaterial includes a polymer electrolyte.
- 25. (Currently Amended) A gas sensor according to claim 24 wherein the conductive massmaterial is a plug, pin, or other shaped component suitable for forming an electrical path between the electrodes and external connections the electrical contact.
- 26. (Currently Amended) A gas sensor according to claim 18 wherein the external connections electrical contact includes the polymer electrolyte.
- 27. (Currently Amended) A gas sensor according to claim 18 wherein external connectionthe electrical contact is a metal strip, or wire, which is attached to the substrategas porous membrane.
 - 28. (Cancelled)
 - 29. (Cancelled)
 - 30. (Cancelled)
- 31. (Currently Amended) A method of forming, an electrical pathway across a microporous membrane having first and second major surfaces; where the which

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microporous membrane in use is impervious to liquid and permeable to gas, comprising the steps of:

- a.) maintaining sufficient heat to melt a conductive material;
- <u>b.)</u> urging the melted conductive material through pores of the <u>microporous</u> membrane at a first surface by establishing a pressure differential across the <u>first and</u> second surfaces;
- <u>c.)</u> controlling the heat and pressure differential until the <u>melted</u> conductive material emerges at the second surface; and
- <u>d.)</u> allowing the material to cool so as to form a continuous, electrically conductive pathway from the first <u>surface</u> to the second surface whilste preserving the liquid impermeability and gas permeability characteristics of the <u>microporous</u> membrane.